

Department of Science and Technology

Republic of the Philippines

CHARACTERIATION, TESTING, AND QUALITY CONTROL OF NANOTECHNOLOGY-BASED PRODUCTS:

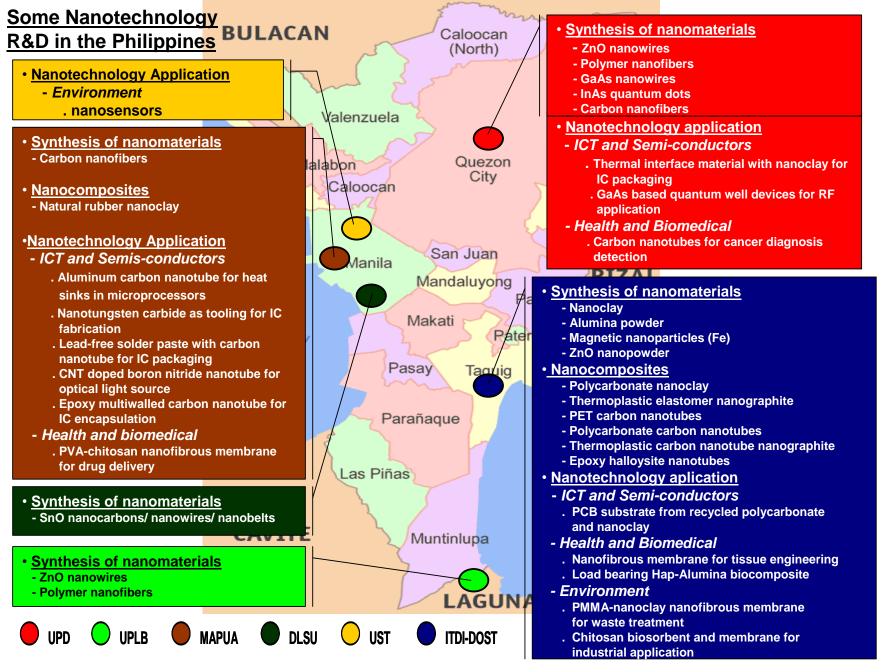
THE PHILIPPINES' CAPABILITIES

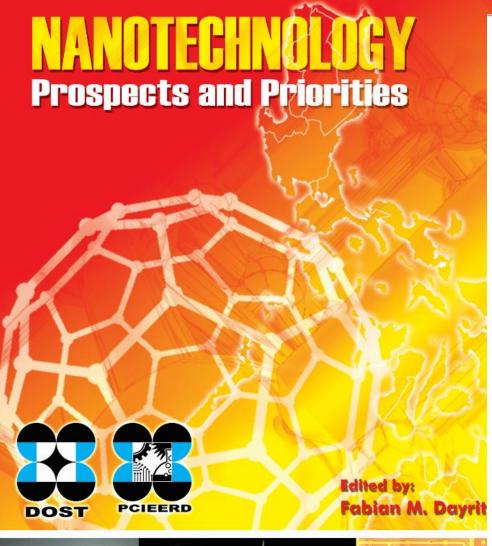
by Blessie A. Basilia, PhD

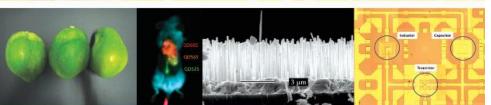
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CHAPTER 1
PROSPECTS AND PRIORITIES OF NANOTECHNOLOGY IN THE PHILIPPINES: AN OVERVIEW
CHAPTER 2
Applications of Nanotechnology in Food, Agriculture, and Forestry
CHAPTER 3
NATURAL NANOMATERIALS FOR POLYMERS AND COMPOSITES
CHAPTER 4
Applications of Nanotechnology in Energy
CHAPTER 5
PROSPECTS AND PRIORITIES IN NANOMEDICINE
CHAPTER 6
Applications of Nanotechnology in ICT and Semiconductors
CHAPTER 7
APPLICATIONS OF NANOTECHNOLOGY TO THE ENVIRONMENT
CHAPTER 8
SAFETY AND RISK ISSUES IN NANOTECHNOLOGY
CHAPTER 9
EDUCATION AND METROLOGY FOR NANOTECHNOLOGY
CHAPTER 10

SUMMARY AND RECOMMENDATIONS: A NANOTECHNOLOGY ROADMAP FOR THE PHILIPPIN

Advanced Device and Materials Testing Laboratory (ADMATEL)



Office Hours: 8AM – 5PM, Monday - Friday Standard ESD Safety Compliance
ISO 17025 ACCREDITED LABORATORY
ISO 9001:2015 Certified

Advanced Device and Materials Testing Laboratory (ADMATEL)

ADMATEL is a DOST national testing facility equipped with advanced analytical instruments for Failure Analysis and Materials Characterization

IT WAS ESTABLISHED:

- To reinforce/ upgrade FA and Materials Testing Facilities of our local industry
- To provide shorter turn-around time
- To provide less expensive analysis
- To attract potential investors seeking for a more conducive business environment







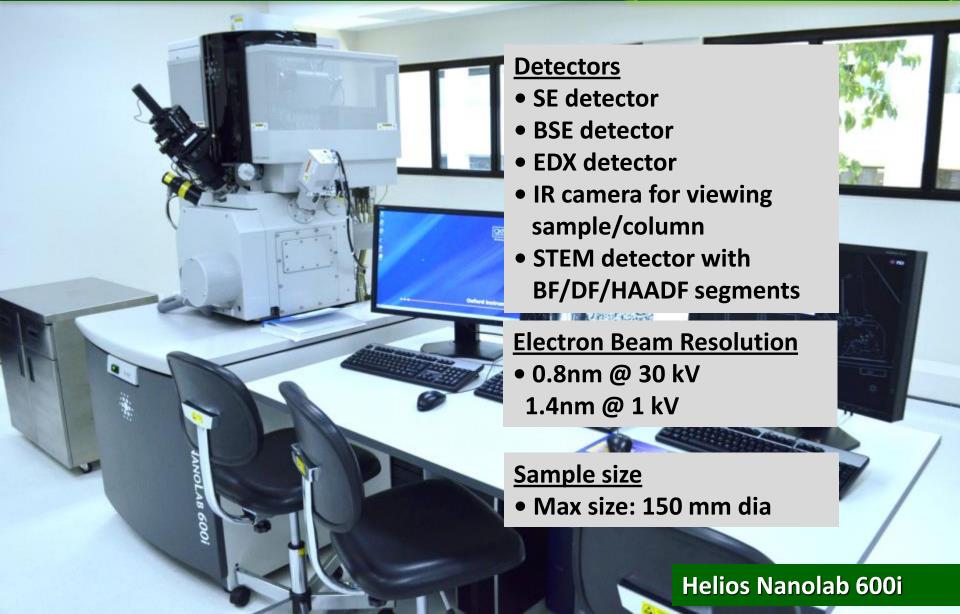
ADMATEL LABORATORIES





FOCUSED ION BEAM (FIB) — FIELD EMISSION SCANNING ELECTRON MICROSCOPE (FESEM)





FIB-FESEM SERVICES

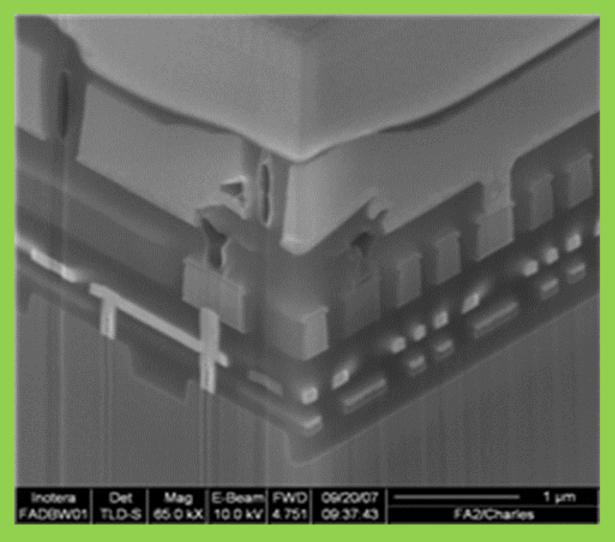


- Defect Analysis
- Failure Analysis
- TEM Lamella Preparation
- Metrology at Nano scale
- STEM analysis
- EDS Analysis
- Site Specific Sample Preparation
- Prototyping for MEMS and NEMS



Site Specific Sample Preparation

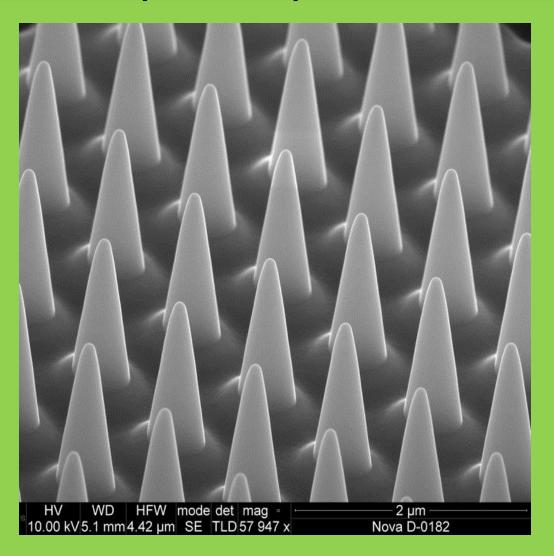




Bi-directional crosssection through an IC device.

Site Specific Sample Preparation

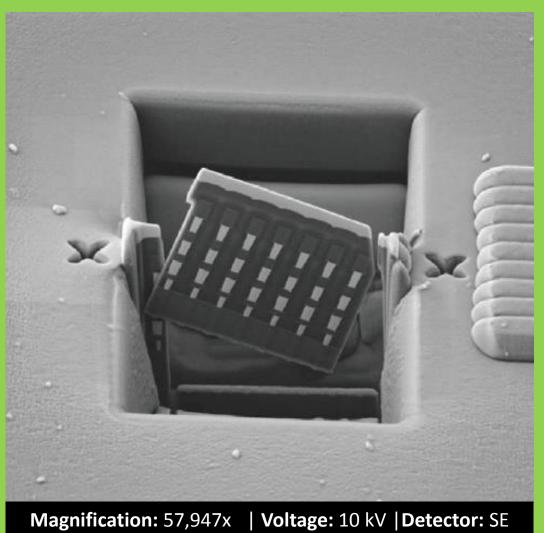




- Field emitters formed by focused ion beam milling.
- Diameter of tip less than 100 nm.

STEM Preparation



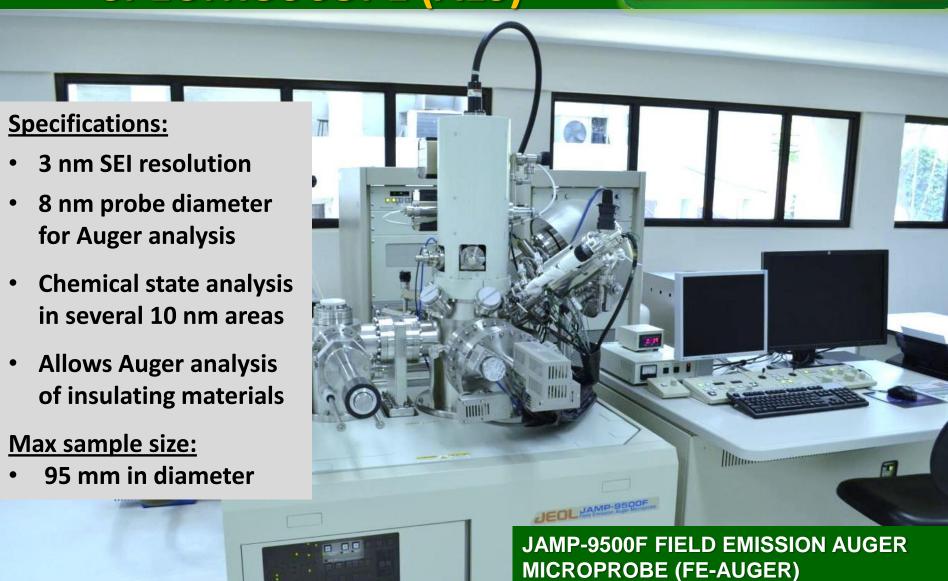


 Created with focused ion beam and ready for transfer to TEM grid.

Spot: 3.0 nA | **Working Distance:** 5.1 mm

AUGER ELECTRON SPECTROSCOPE (AES)





AES TESTING SERVICES



- Depth profile analysis
- Spectrum Measurement
- Surface map analysis
- Line analysis measurement
- Element identification
- Insulator material analysis
- Elemental microanalysis (≤1 atomic percentage)
- Imaging of part analysis (max magnification 500k)



TIME-OF-FLIGHT SECONDARY ION MASS SPECTROMETER (TOF-SIMS)

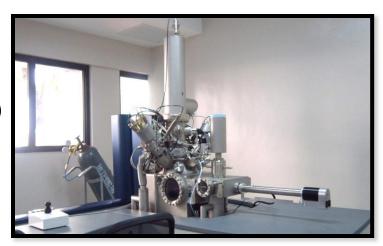




TOF-SIMS SERVICES



- Trace Metal Detection / Quantification
 - simultaneous detection of all elements (ppm/ppb range)
 - small surface areas (patterned wafers)
 - in depth distribution
 - backside contaminants
- Screening for Contaminants
 - inorganic and organic
 - particle analysis
- Gate Oxide analysis
 - Ultra-thin dielectric layers (Oxinitrides, High-k)
 - nitrogen content, oxide thickness
- Analysis of shallow Implants
 - high sensitivity
 - parallel mass detection (contaminant screening)
 - Failure analysis
 - Interface, bond pad, test pad analysis
 - Defect and particle analysis



FTIR SPECTROSCOPY AND IMAGING



- Failure analysis
- Micro-contamination identification
- Adhesive performance
- Material delamination
- Corrosion chemistry

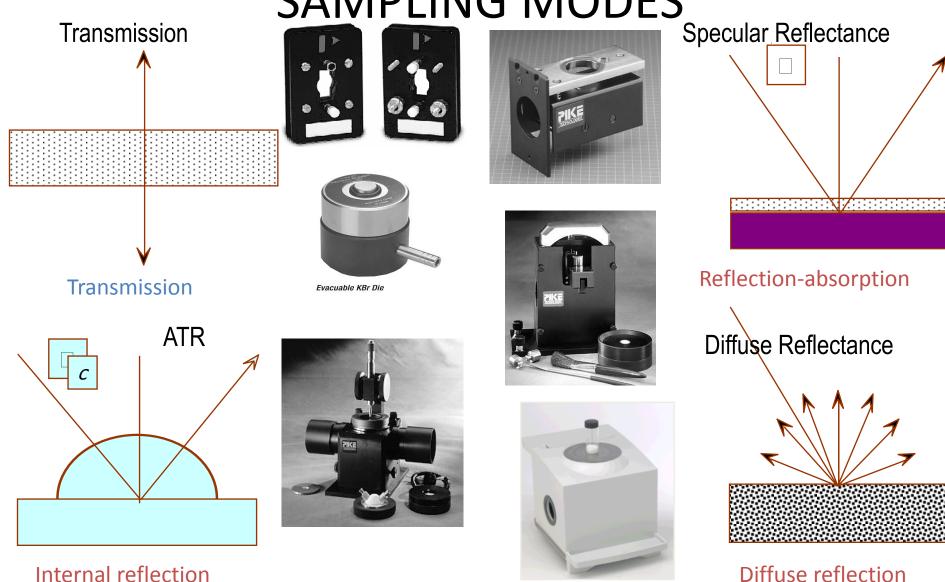


- Analysis of inhomogenieties in a larger matrix
- Surface studies/characterization



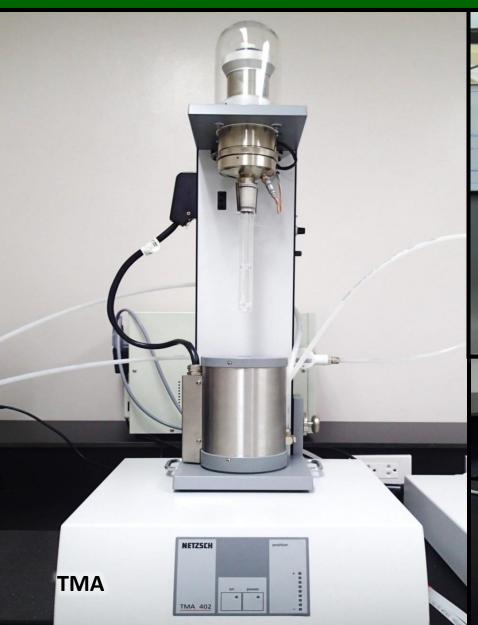
INFRARED

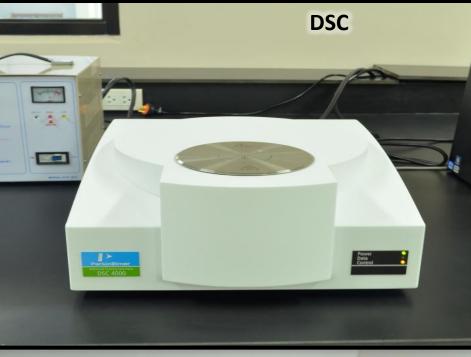
SAMPLING MODES



THERMAL ANALYSIS EQUIPMENT









SAMPLE PREPARATION AND EXTERNAL VISUAL INSPECTION





DIAMOND SAW

ION CROSS-SECTION POLISHER





OPTICAL MICROSCOPES

TESTING SERVICES



Equipment	Services	Description	Application
TG-DTA and FTIR	Hyphenated TG- FTIR analysis	Simultaneous analysis of evolved gases and % weight loss during heating.	Compositional Analysis of Materials, Reverse Engineering
Auger Electron Spectroscopy	Chemical State Analysis	Determines the chemical state of selected elements	Used to verify the composition of oxide layer found in leadframe pads or delaminated interface.
DSC	Kinetics Study	Thermal analysis study by varying the soak time at constant temperature	Determination of curing time for epoxies.
TMA	Determination of Coefficient of Thermal Expansion	Measures the dimensional change of sample in one (1) axis during heating	Determination of CTE and Tg for Metals, ceramics, polymers, and composites.

TESTING SERVICES

at Wide Mass

Range



analysis

	DIIIVO DEK		urraic L
Eqpt	Services	Description	Application
TMA	Determination	Measures the	Polymeric
	of Glass	dimensional change	materials
	Transition	of sample in one (1)	

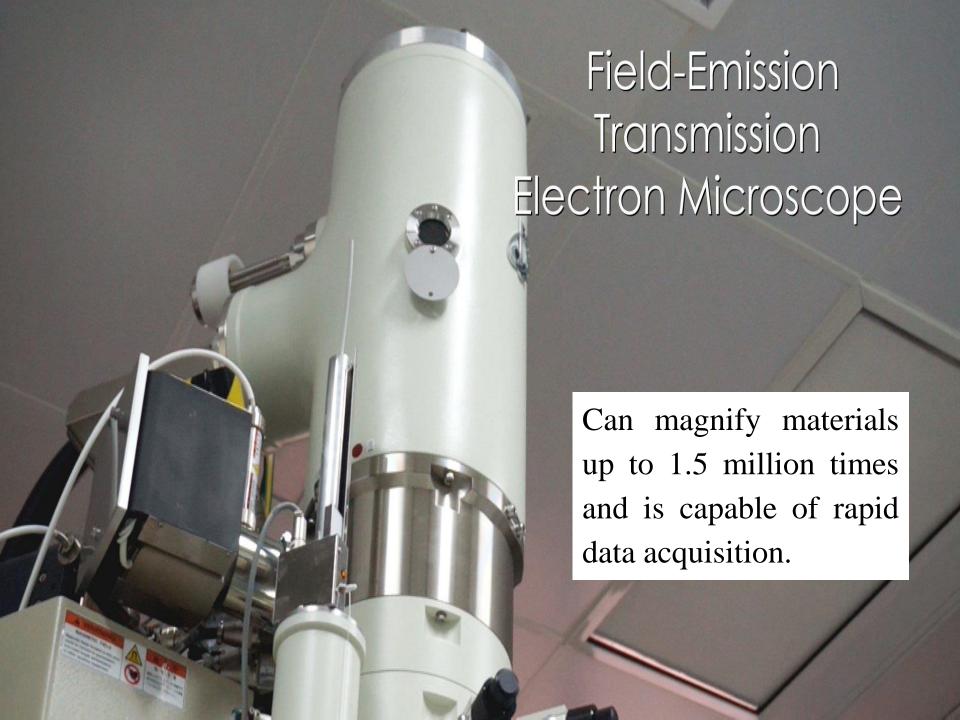
	Temperature	axis during heating	
FIB-FESEM	STEM Imaging	Determines the	Defect
	with EDS	elements present in	analysis
	analysis	the sample	

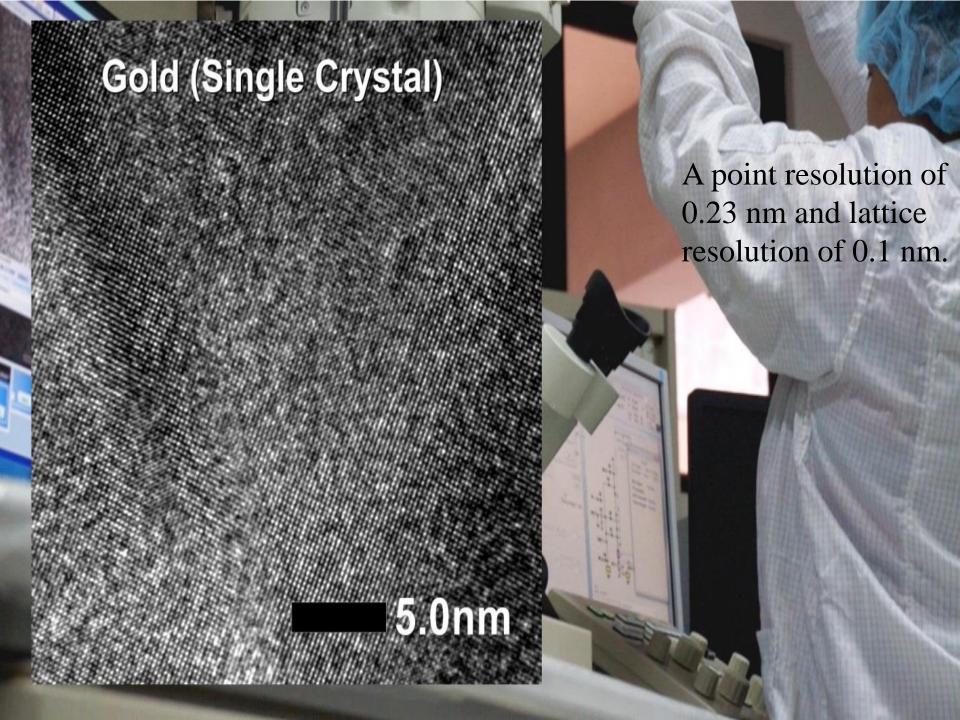
TOF-SIMS Depth Profiling Depth Profile Defect

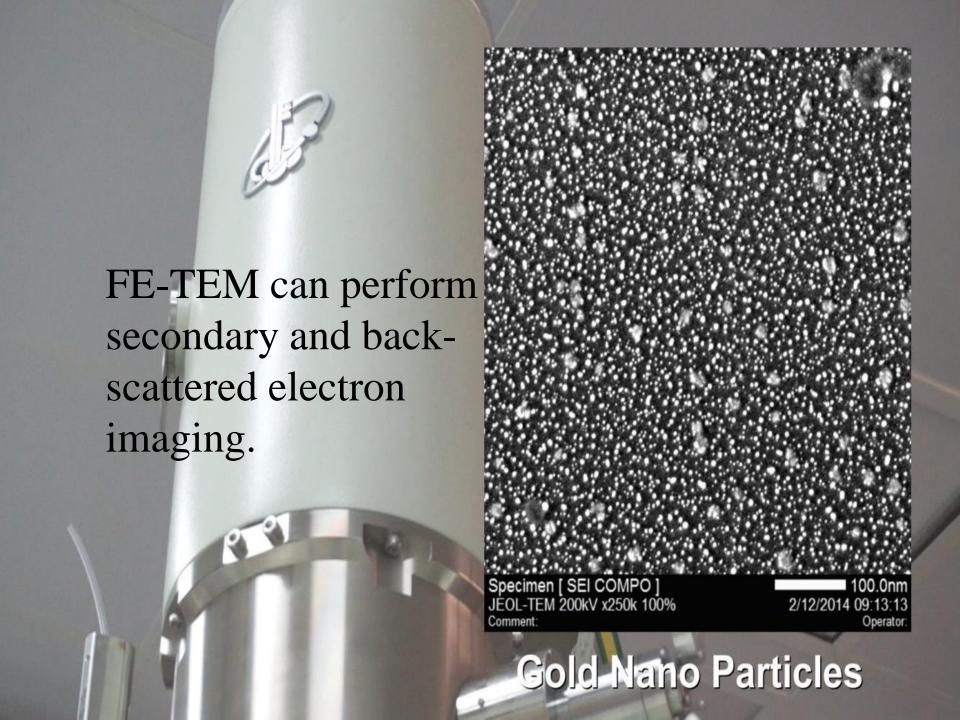
Analysis at >400

mass units









Selected Area Electron Diffraction Capability 0.23 nm 10 nm Gold Nano Particles

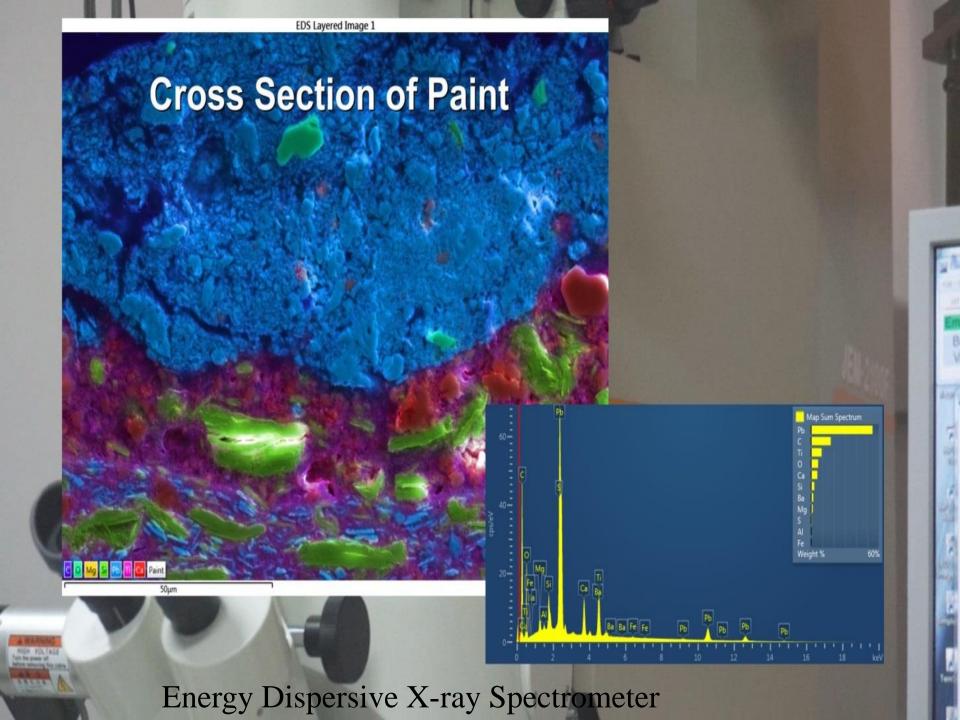
Dark Field Specimen [STEM DF] JEOL-TEM 200kV x250k 100% 2/12/2014 09:32:12

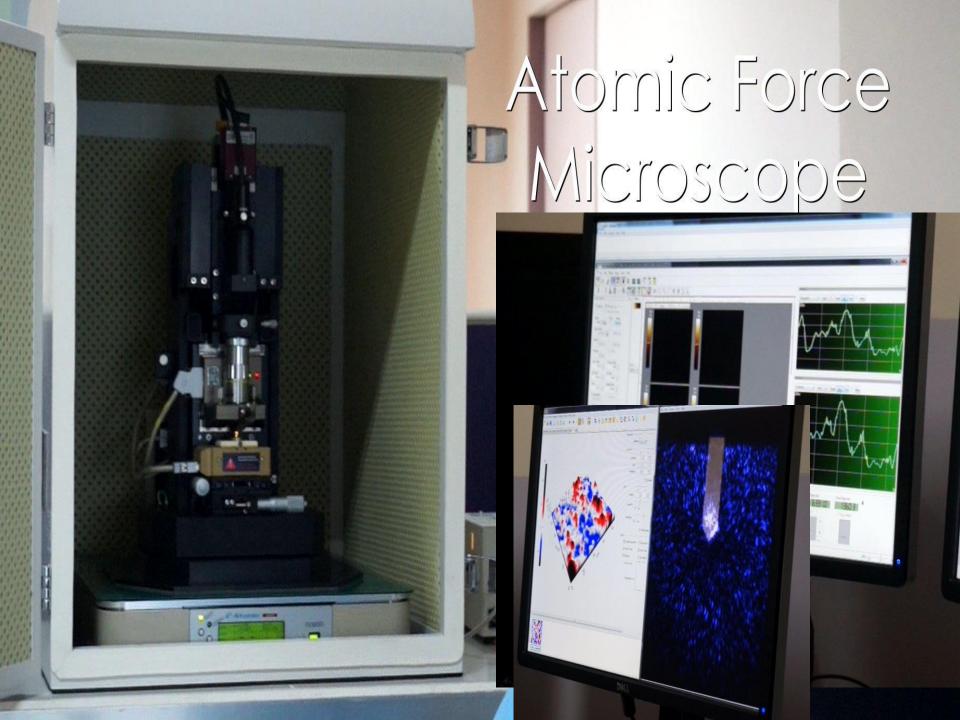
Bright Field

Specimen [STEM BF] JEOL-TEM 200kV x200k 100%

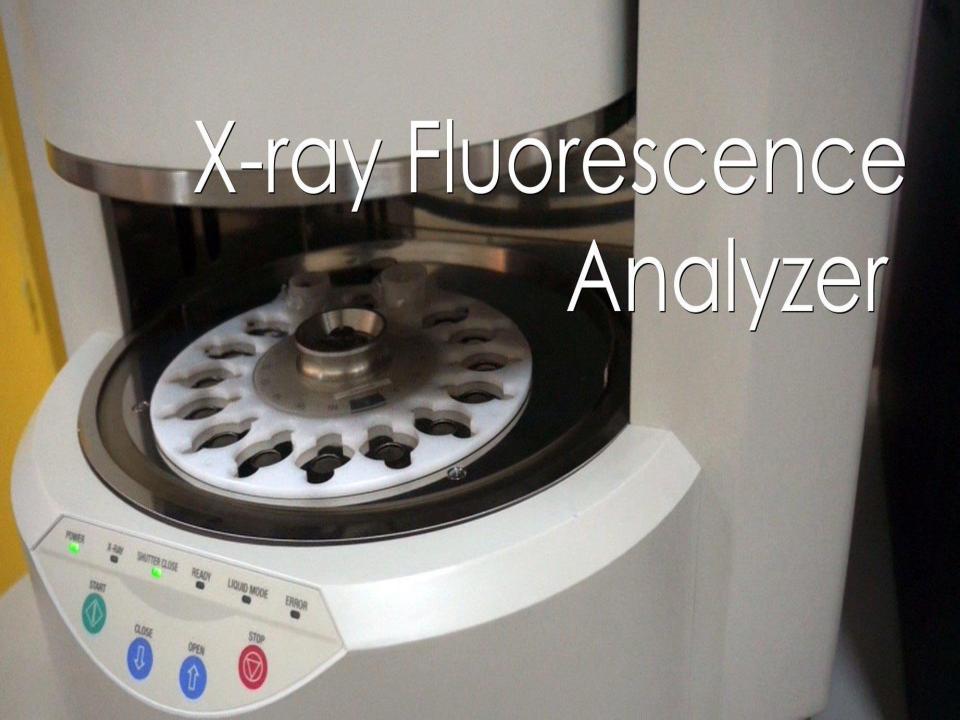
200.0nm 2/12/2014 09:36:32 Operator:

Gold Nano Particles

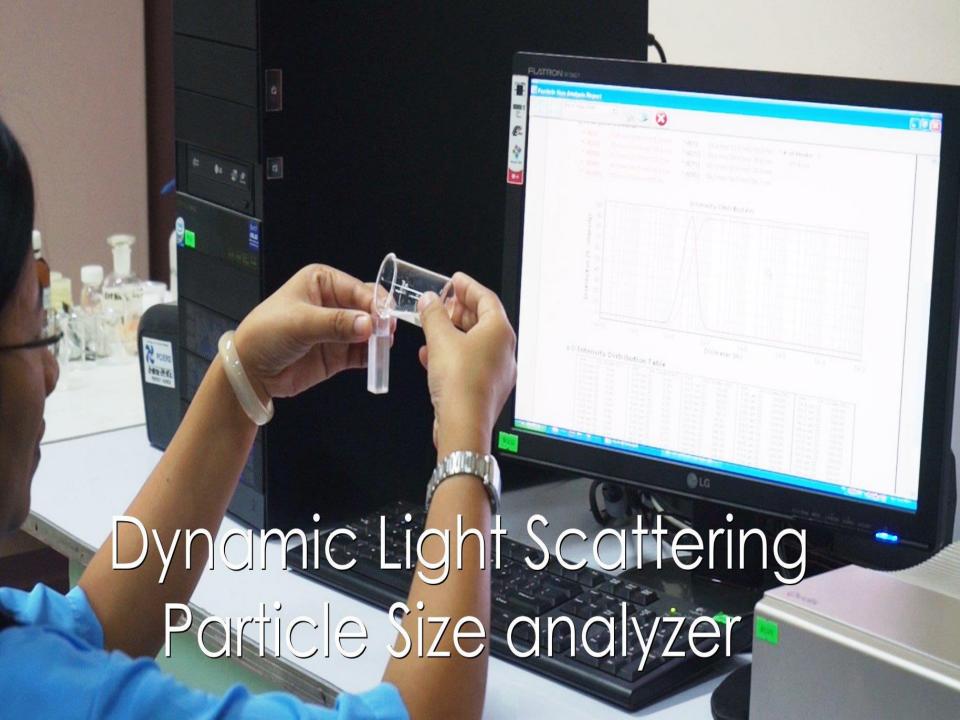












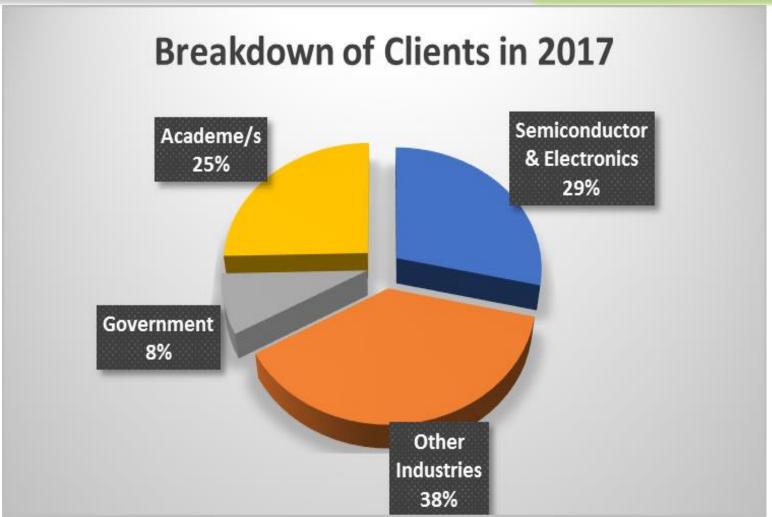


OPERATION UPDATE

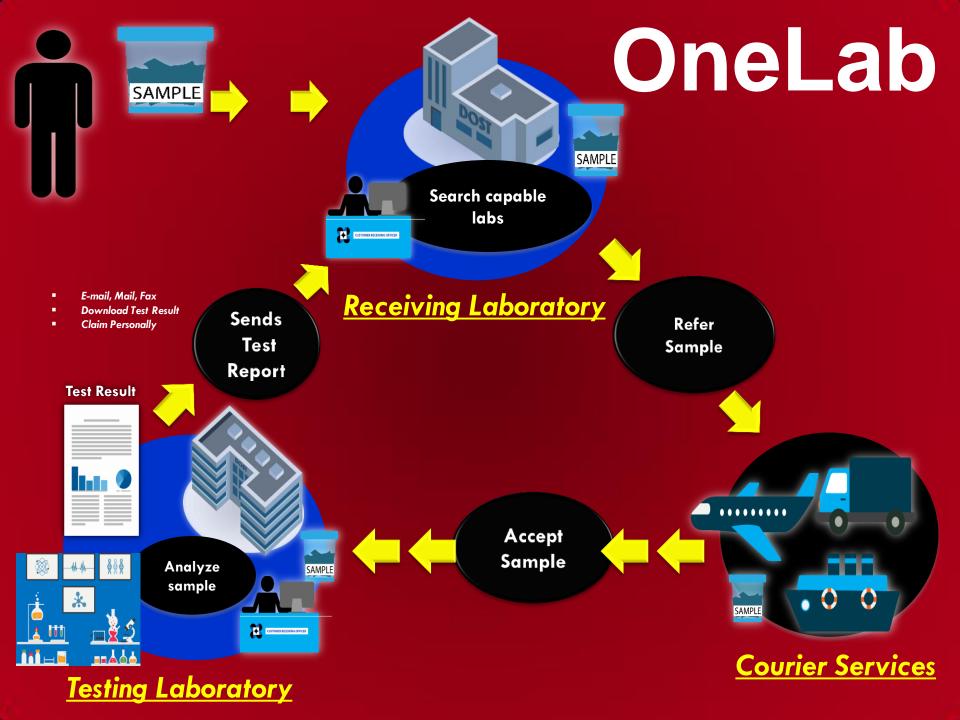


CLIENTS





Objectives of test request: Quality Assurance, Materials Qualification, Reliability, Market Quality and Research



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